

AF 2823



Corres. and Mail
BOX AF

Attention: Mail Stop AF
Response Under 37 C.F.R. § 1.116
Expedited Procedure Requested
Examining Group 2823

PATENT
Customer No. 22,852
Attorney Docket No. 04329.2622

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Gaku MINAMIHABA, et al.)
)
Serial No.: 09/932,943)
)
Filed: August 21, 2001)
)
For: SLURRY FOR CHEMICAL)
MECHANICAL POLISHING AND)
METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)

Group Art Unit: 2823
Examiner: Lee, Hsien Ming

RECEIVED
JUL 31 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL AMENDMENT AFTER FINAL

Supplemental to the Amendment After Final filed on July 24, 2003, Applicants propose further amending the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.

FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP
1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com